



Attorney Docket No. 277/013

EFN

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Kyu-Dong JUNG, et al.

Art Unit: 2813

Serial No. 10/701,552

Examiner: Monica D. HARRISON

Filed: November 6, 2003

Confirmation No. 8318

For: METHOD AND APPARATUS FOR VACUUM-  
MOUNTING A MICRO ELECTRO  
MECHANICAL SYSTEM ON A SUBSTRATE

**STATUS INQUIRY**

Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Kindly advise the applicant by return mail as to the current status of the captioned application and the date on which the next Action on the merits may be expected.

Respectfully submitted,

February 1, 2006

Date

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